



ELECTRONIC COPY

LG758557245
Report verification at igi.org



December 20, 2025

IGI Report Number **LG758557245**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **10.11 X 6.79 X 4.54 MM**

GRADING RESULTS

Carat Weight **3.10 CARATS**

Color Grade **F**

Clarity Grade **VVS 2**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

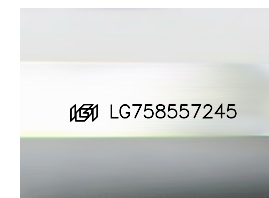
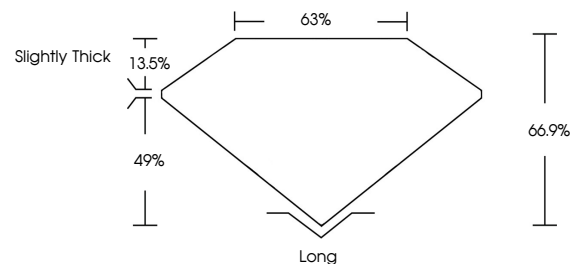
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **LG758557245**

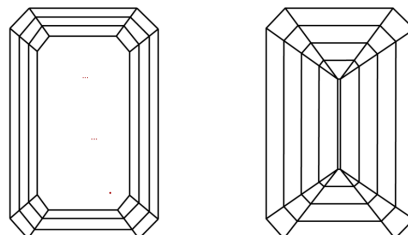
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

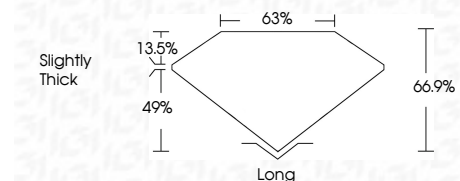
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

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IGI



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IGI Report No **LG758557245**
EMERALD CUT

10.11 X 6.79 X 4.54 MM

Carat Weight **3.10 CARATS**
Color Grade **F**
Clarity Grade **VVS 2**
Table **66.9%**
Girdle **65%**
Culet **Slightly Thick**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **LG758557245**

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